

<b>Notice of References Cited</b>		Application/Control No. 09/342,348	Applicant(s)/Patent Under Reexamination BROSNIHAN ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-4631803	12-1986	Hunter et al.	438/426
	B	US-5747353	05-1998	Bashir et al.	438/50
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	M. de Boer et al., The Black Silicon Method V: A Study of The Fabricating of Movable Structures for Micro Electromechanical Systems. IEEE 1995, pp. 565-568.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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